## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Masaki Aoki et al.

Group Art Unit: 1722

Serial No.: 09/997,536

Confirmation No.:7590

Filed: November 29, 2001

November 1, 2007

For: METHOD OF PRODUCING PLASMA

DISPLAY PANEL WITH PROTECTIVE

LAYER OF AN ALKALINE EARTH OXIDE

Costa Mesa, California 92626

## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop Issue Fee Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. § 1.97(i) Applicant wishes to place of record in the file the following references:

Japanese Patent Application Publication 61-287032 with corresponding US Patent

4,717,584

Japanese Patent Application Publication 2001-104774 w/English Abstract Japanese Patent Application Publication 2004-170394 w/English Abstract Korean Patent Application Publication 90-008640 with corresponding US Patent

4,926,095

Fujii, E. et al, "NaCl-type Oxide Films Prepared by Plasma-Enhanced Metalorganic Chemical Vapor Deposition", Japanese Journal of Applied Physics, Part 2 (letters), Vol. 32, No. 10A, L1448-L1450, October. 1, 1993.

Copies of the foreign references, non patent literature document and Form PTO-A820 are attached.

These references are not deemed to be more material than the reference applied in and of record but are cited to have the reference of record in the file.

Very truly yours,

SNELL & WILMER L.L.P.

Joseph W. Price, Reg. No. 25,124 606 Anton Boulevard, Suite 1400 Costa Mesa, CA 92626-7689

Tel: 714-427-7420 Fax: 714-427-7799

2